









Tricyclononenes: New Alicyclic Monomers for 157 nm Photoresists

Daniel P. Sanders, Eric F. Connor, and Robert H. Grubbs

Department of Chemistry Arnold and Mabel Beckman Laboratory of Chemical Synthesis California Institute of Technology

Raymond J. Hung, Brian P. Osborn, and C. Grant Willson Departments of Chemistry and Chemical Engineering University of Texas - Austin